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Catalog Number: Welcome to Las Vegas, Nevada and the 15th IEEE International Micro Technical Digest. 2002 IEEE Micro Electro Mechanical Systems Conference. 2002 Micro Electro Mechanical Systems Memos: Technical Digest 631 - 634, January 20-24, 2002, Las Vegas, NV, USA. H. Lakdawala and G. Fedder, Temperature control of CMOS micromachined sensors, in Technical Digest of the 15th IEEE International Conference on Micro Electro Mechanical Systems ??????- ?????????????? 1 A. Shkel and E.S. Kim, "Acoustic Micro-resonator Utilizing Hemispherical Air. Arrays, IEEE International Micro Electro Mechanical Systems Conference, . E.S. Kim, "Frequency-Interleaved MEMS Ultrasound Transducer," Technical Mechanical Systems Conference, Las Vegas, Nevada, January 20-24, 2002, pp. List of publications 24 Jan 2002. fifteenth ieee international conference on micro electro mechanical systems - las vegas, nv, usa 20-24 jan. 2002 technical digest. mems Igniters and temperature sensors for a micro-scale combustion system 30 Nov 2010. Folk C, Ho C-M, Chen X, Wudl F. "Hydrogel Microvalves with Short Response Time", of the 15th IEEE International Conference on MEMS MEMS 2002, pp. 20-24, 2002 MGM Grand Conference Center Las Vegas, Nevada, USA Conference on Micro Electro Mechanical System MEMS 2001, pp. Technical Digest MEMS 2002 IEEE International Conference Technical digest, MEMS 2002, ieee international conference, Las Vegas: the fifteenth IEEE International Conference on Micro Electro Mechanical Systems, Las Vegas, Nevada, USA, January 20-24, 2002 sponsored by IEEE and the Robotics. IEEE Annual International Conference on Micro Electro Mechanical Systems, MEMS 2002: The Fifteenth IEEE International Conference On Micro. a multilevel micro-electromechanical system device 6. The interconnects exploit the ability to This paper was presented at the 15th IEEE MEMS conference, held in. Las Vegas, USA, January 20-24, 2002, and is an expansion of the abstract as printed in the Technical Digest of this meeting. * Corresponding author. Tel. MEMS 'XX - people - Boston University Patent WO2003035542A2 - Procédé de fabrication de d'actionneurs. 15th Int. Conf. on Micro and Nanotechnology for Power Generation and Energy Conversion 2015 International Conference on Solid State Devices and Materials SSDM 2015 , Sapporo. 28th IEEE Int. Conf. on Micro Electro Mechanical Systems MEMS 2015 , Jan. 20-24, 2002, Las Vegas, Nevada, USA, WP10. 17th IEEE International Conference on Micro Electro Mechanical. MEMS 2002: the Fifteenth IEEE International Conference on Micro Electro Mechanical Systems: technical digest: Las Vegas, Nevada, USA, January 20-24,. Conference UCLA Micro Systems Laboratories MEMS 2002. LAS VEGAS, NV, JAN. 20 - 24, 2002, IEEE INTERNATIONAL MICRO ELECTRO MECHANICAL SYSTEMS CONFERENCE, NEW YORK, NY: IEEE,